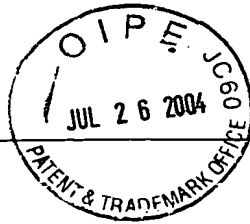


Application Serial No: New Application  
Inv: Akira HOKAZONO, et al.  
Preliminary Amendment  
Oblon Docket No: 239757US-2 DIV



DOCKET NO: 239757US-2 DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
AKIRA HOKAZONO, ET AL. : EXAMINER:  
SERIAL NO: NEW APPLICATION :  
FILED: HEREWITH : GROUP ART UNIT:  
FOR: SEMICONDUCTOR DEVICE AND :  
METHOD OF MANUFACTURING THE  
SAME

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

COPY